





Solutions for precision optics.

Customer benefits are our daily business.



As an important step toward expanding the Advanced Materials Business within Bühler with a strategic focus on environmentally friendly and energy-saving technology, Leybold Optics was acquired in May 2012. With this acquisition, Leybold Optics became part of a family-owned conglomerate of specialists and technology partners for plant, equipment and services for manufacturing advanced materials and for processing basic foods. Not only does Bühler now hold the leading market position in the field of aluminum die casting, transforming grain into flour and feeds, and making pasta and chocolate, but also in vacuum thin-film coating.

Within Bühler, we are stronger than ever and in an even better position to drive our most modern coating solution, process expertise and 1st class service and thus maintain our leading role in optical thin-film vacuum deposition equipment. Over the next few years, we want to focus on our existing expertise in emerging markets with our most eco-friendly coating solution and an outstanding cost-performance ratio. Additionally, we will invest in high-quality technology for developed markets to provide new applications.

We are centering our efforts on ensuring our customers' success by improving our core-component technologies with a strong focus on cost of ownership. Our advances, for example in architectural layer-stack design, aim not only for performance and reliability but also for cost efficiency.

Every year we spend a significant amount on basic research and applied development to further improve our technology with regard to quality and precision, sustainability, serviceability and the ecological footprint of our design and systems.

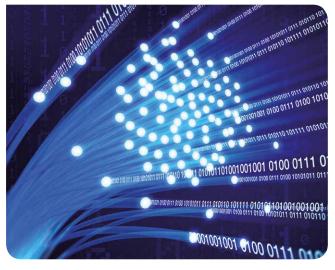
Sincerely yours

Antonio Requena

Managing director Bühler Alzenau GmbH Leybold Optics









Leybold Optics – portfolio overview.

Solutions for every challenge.



SYRUSpro series

Our SYRUSpro vacuum coater series sets the industry benchmark in production and R&D. This classic evaporation system produces excellent coatings at extremely competitive deposition rates and is also available in special configurations for infrared (IR) and ultraviolet (UV) wavelength regimes.

Page 8



ARES series

High productivity, lowest cost of ownership, production-proven. These are the highlights of the ARES series that has been developed to meet the requirements of mass-production-oriented markets, especially in Asia.

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HELIOS series

The HELIOS series sputtering tool is a flexible platform for fast, precise and fully-automated thin-film coatings. It specializes in high-quality optical coatings featuring very low absorption and scattering.

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LEYBOLD OPTICS IBS

LEYBOLD OPTICS IBS Technology is a proven technology for lowest absorption and scattering capabilities for high-end optical applications.

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NESSY series

The NESSY series is our latest-generation magnetron-sputtering system mainly used for the production of extreme ultraviolet (EUV) mirrors under ultra-high vacuum (UHV) conditions – for mass production and product development.

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DEIMOS

Astronomical substrates of up to 4.5 m in diameter can be precisely sputtered within DEIMOS coaters, achieving highest reflectivity and durability values. The ease of substrate exchange is another noteworthy advantage.

Page 26



STARpro

Based on a single-reactive magnetron configuration, the STARpro allows the manufacture of multiple-layer stacks consisting of ${\rm SiO_2}$ and ${\rm Si_3N_4}$. Its versatility combined with its ultra-compact design makes it a perfect choice for small production runs.

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LEYBOLD OPTICS DLC

This high-vacuum coater uses plasma-enhanced chemical-vapor deposition (PECVD) technology for material deposition. The diamond-like carbon coatings produced are mainly used for optical- and thermal-imaging systems.

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OPTEG OMF series

This ion beam figuring (IBF) technology is a dry error correcting and polishing process for the production of high-performance optics. While conventional polishing techniques reach their limits IBF is the ideal solution to achieve ultra-precise surface finishes.

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SYRUSpro series.

Unsurpassed performance and productivity.



- 1 Planetary systems, calottes or full-domes
- 2 Proprietary optical monitoring systems
- 3 Optimized heater assembly (bottom and/or top)
- 4 Ergonomic human-machine interface
- 5 Pre-installed processes

- 6 Network integration and remote access
- 7 Customized thermal evaporator setups
- 8 Proprietary electron-beam guns
- 9 Proprietary plasma sources

Applications:

- Edge filters (short and long pass)
- Notch filters
- Narrow bandpass filters
- Dichroic color filters
- Polarization beam splitters
- (Super) AR coatings

- Endoscopes
- Laser mirrors
- Cold-light mirrors
- TCO layers
- Self-assembled nanostructures

SYRUSpro series -

the benchmark for 24/7 optical-filter volume production

The SYRUSpro series is quite simply the industry benchmark in production and R&D. Decade-long perfection of plasma-ion-assisted deposition (PIAD) technology enables excellent coatings at extremely competitive deposition rates from deep-ultraviolet (DUV) via visible spectrum (VIS) up to the infrared (IR) spectral range.

Based on a large variety of proprietary components and Bühler Leybold Optics process control, the SYRUSpro series is customized to meet the most challenging individual needs.

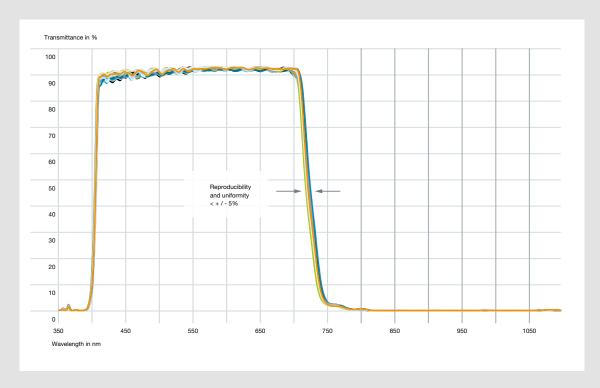
With optical and/or physical monitoring to control layer growth, Bühler Leybold Optics' SYRUSpro series delivers extremely high spectral performance and unmatched reproducibility at lowest cost-per-piece, thus maximizing the return-on-investment.

Key benefits:

- Far IR to deep UV wavelength spectrum
- Co-evaporation from two sources, with dual-rate and thickness control
- Leybold Optics LION and APSpro ion sources
- Integrated proprietary optical monitoring system
- Outstanding versatility through variety of options
- Eight different chamber sizes (700 up to 2800 mm)
- Substrates up to 1.1 m in size
- Fully modular and customizable concept
- Benchmark in cost-per-piece

Unique reproducibility and precision

Reproducibility and uniformity of 5 consecutive batches and 5 substrates for each run distributed over a single calotte of a UV-IR-cut filter produced in a SYRUSpro 1510.



The 25 different curves show only minimal deviations – a remarkable result.

SYRUSpro series.

Manifold options and peerless flexibility.



SYRUSpro series - a universe full of options

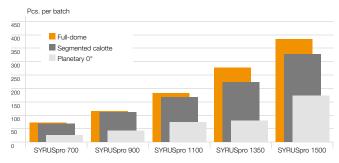
The enormous range of options in the equipment of a SYRUS-pro coater is one of its key features that make the difference and allows a perfect match to customer needs. The process library and the company's experience with challenging specifications for IR, DUV and even extreme wavelength regimes are unrivaled in the industry.

Ultimately, it is the wealth of knowledge and experience that allows the Bühler Leybold Optics process experts to realize the one configuration that best matches the specific customer requirements. They understand the often complex interrelationships and come up with the ideal coater – almost always a SYRUSpro.

Broadest portfolio and experience in the market

Able to offer up to 8 different chamber sizes, Bühler Leybold Optics has the broadest experience to provide the perfect matching solution for any kind of business case.

Loading capacity Ø 65 mm lenses



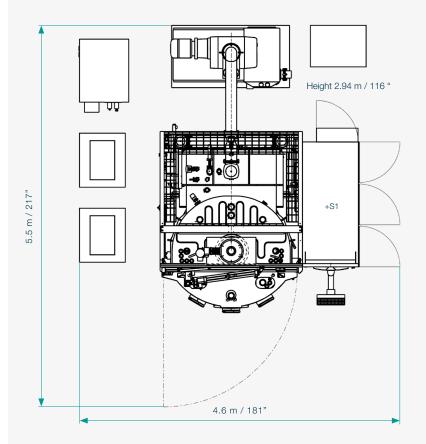
Enlargement of chamber size is only possible with adequate components so as not to compromise coating quality.

Technical data

SYRUSpro	700	900	1100	1350	1500	1950	2100	2800
Coating technology	Ion-assiste	d deposition	(IAD), plasma	-ion-assisted	deposition (F	PIAD)		
Coating materials	Every com	monly used n	naterial (diele	ctrics, metals	, fluorides, su	lfides)		
Chamber width [mm]	700	900	1100	1350	1500	1950	2100	2800
Chamber width [inch]	28	36	44	53	61	77	83	110
Floor space [m²]	11.2	16.4	17.3	20	25.9	38	41	55
Floor space [sq.ft.]	121	177	186	215	279	409	441	592
Loading capacity Ø 65 mm								
Calotte [pcs.]	71	115	183	277	384	*	*	*
Segmented dome [pcs.]	3 x 23	3 x 37	4 x 42	4 x 56	6 x 54	*	*	*
Planetary system [pcs.]	25	43	73	79	112	*	*	*

^(*) To be defined in accordance with customer requirements

SYRUSpro 1510



Pumping systems:

- Fore-vacuum:
 - Standard pumps
 - Dry pumps
- High-vacuum:
 - Turbomolecular pumps
 - Diffusion pumps
 - Cryogenic pumps

Heating systems:

- Precise temperature ramp-up
- Optional:
 - Front or rear-side heating
 - Ceramic or metal heaters
 - Control via thermocouple or pyrometric, intermittent on substrate
 - High- or low-power sources
- High-temperature option (> 400° C)

Premium components for SYRUSpro.

Substrate holders



Pallet substrate holders for



Segmented domes in variety of configurations



High-precision full-domes for fast loading times



Planetary drive-systems with double-rotation

Evaporators



LEYBOLD OPTICS HPE 12/10 mid-size electron-beam gun



LEYBOLD OPTICS HPE 12 large-volume electron-beam gun



Single-boat thermal-resistance evaporator



Triple-boat thermal-resistance evaporator

Optical monitoring

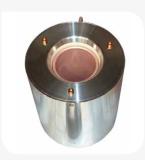


Single-wavelength monitoring system LEYBOLD OPTICS OMS 5100



Broadband optical-monitoring system LEYBOLD OPTICS BBM

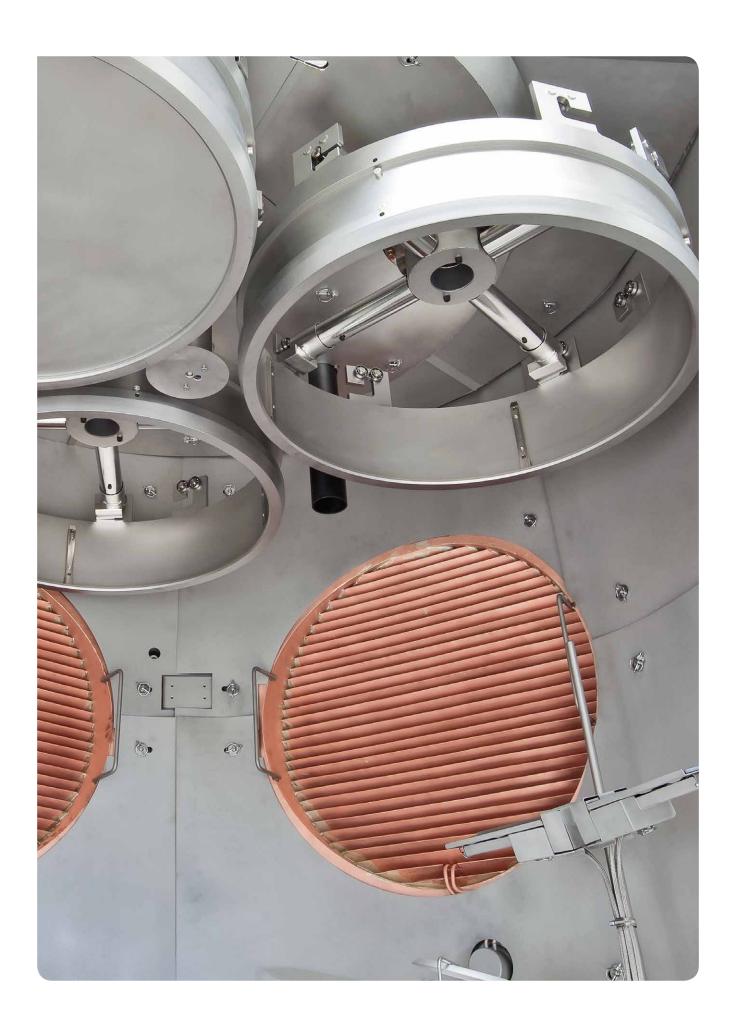
High-power plasma sources



LEYBOLD OPTICS APSpro with LaB6 cathode



LEYBOLD OPTICS LION 300 based on ECWR



ARES series.

Getting the optimum in value for your investment.



- 1 Quartz-crystal monitoring
- 2 Optical monitoring system
- 3 Visualization in Chinese
- 4 Network connection and remote access
- 5 Fully-modular concept
- 6 Compact footprint
- 7 Proprietary ion sources
- 8 Proprietary electronbeam guns
- 9 Optimized equipment configuration

ARES series - cost-effective production with high performance

The ARES series is Bühler Leybold Optics' system for cost-optimized mass-production of optical components especially designed for East Asian countries.

The configuration is thoroughly streamlined according to the specific application, but never compromising on quality – a smart choice for the savvy investor.

Applications:

- AR coatings
- Anti-fingerprint coatings
- Color filters
- Edge filters
- Cold-light mirrors
- Touch screens

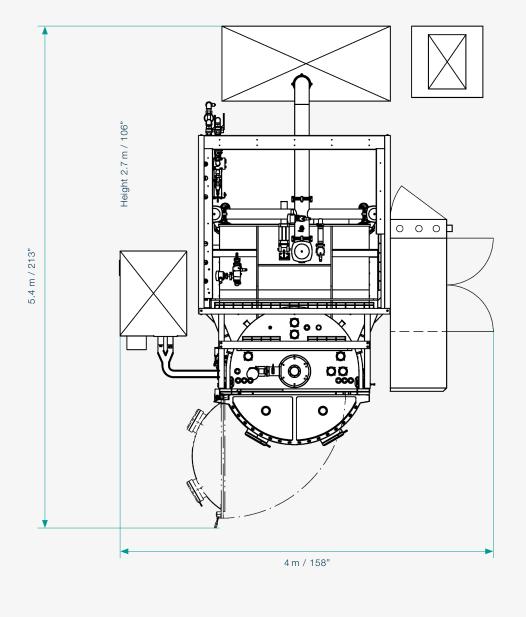
Key benefits:

- Optimum CAPEX performance ratio
- Optimized for East Asian requirements
- High throughput

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Systems	ARES 700	ARES 1100	ARES 1350	ARES 1500	ARES 2000	
Coating materials	All commonly used	All commonly used dielectrics, metals, fluorides, sulfides				
Coating technology	Ion-assisted deposit	tion (IAD) / Plasma-ion	-assisted deposition (F	PIAD)		
Chamber diameter [mm]	700	1100	1350	1500	1960	
Chamber diameter [inch]	28	44	53	61	77	
Floor space [m ²]	11.2	20	23.7	25.9	38	
Floor space [sq.ft.]	121	216	255	279	409	
Loading capacity Ø 65 mm						
Calotte [pcs.]	71	186	277	324	*	
Segmented dome [pcs.]	3 x 23	4 x 42	4 x 63	6 x 54	*	
Planetary system [pcs.]	25	73	79	112	*	

ARES 1350



HELIOS series. **High-precision**, high-yield coaters for top-grade products.



HELIOS series - the ultimate sputter coaters

This flexible sputter platform is ideal for fast, precise and fully-automated thin-film deposition. It specializes in high-quality optical coatings, featuring very low absorption and scattering.

Unsurpassed optical performance is ensured by the extremely dense, smooth, stoichiometric, and amorphous layers. Ultimate precision in layer-growth control is facilitated by an optical monitoring system for in-situ on-substrate measurements.

Key benefits:

- PARMS process technology
- No arcing and µ-arcing
- High and stable deposition rates
- On-substrate optical monitoring
- Extremely high process stability
- Thickness precision down to ultra-thin layers
- Filters with over 200 layers and 20 µm thickness
- Optimal film oxidation,
 high density and low loss
- Co-sputtering for intermediate index tuning
- Rapid prototyping and short time-to-market
- Fast (un)loading without breaking the vacuum

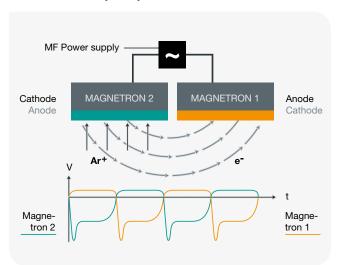
Applications:

- Laser-line filters
- Steep-edge filters
- Single- and multi-notch filters
- Laser mirrors
- Chirped mirrors
- Thin-film polarizers
- Beam splitters
- Bio sensors

PARMS process technology

The plasma-assisted reactive magnetron-sputtering (PARMS) technology allows for the deposition of metal oxides with high-and low-refractive indices by combining mid-frequency (MF) and radio-frequency (RF) sputter technologies over two magnetrons.

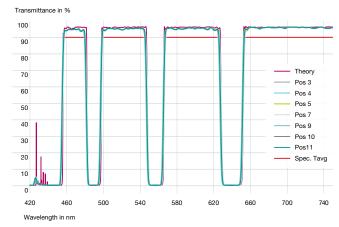
Parms technical principle:



On-substrate optical monitoring

The LEYBOLD OPTICS OMS 5100 is the premium tool for in-situ optical monitoring. The optical thickness of the coated layer is measured either on a stationary test-glass or – for more accuracy – directly on the substrate via intermittent mode.

4-fold-notch filter, AOI = 10°



One example of how theory and prototype coating of an advanced notch filter perfectly matches when produced with HELIOS coaters.

Technical data

System			HELIOS 400	HELIOS 800	
Technology			Plasma-assisted reactive magnetron-sputtering (PARMS)		
Applications			DC sputtering (optional: HF sputtering)		
Coating material			SiO_2 , Nb_2O_5 , Ta_2O_5 , ZrO_5 , HfO_2 , AIO_3 , Si_3N_4		
Capacity			12* pcs. at Ø 125 mm / 5"	12* pcs. at Ø 200 mm / 8"	
			16* pcs. at Ø 100 mm / 4"		
Source positions (max. 4)	1 and 2	(standard)	Dual-magnetron	Dual-magnetron	
	3	(optional)	Single-magnetron	Dual-magnetron	
	4	(standard)	RF plasma	RF plasma	
	Coating Ø	(standard)	≤100 mm / ≤ 4"	≤ 200 mm / ≤ 8"	
		(optional)		≤ 150 mm / ≤ 6"	
Layer monitoring	Time contro	ol	Yes	Yes	
	Optical mor	nitoring	LEYBOLD OPTICS OMS 5100 LEYBOLD OPTICS BBM	LEYBOLD OPTICS OMS 5100 LEYBOLD OPTICS BBM	
Dimensions	Width x len	gth x height	5.7 m x 3.4 m x 2.6 m 223" x 134" x 102"	7.3 m x 6.2 m x 3.0 m 288" x 242" x 118"	
Site requirements Electric power		46 kVA	110 kVA		
	Line voltage	€	400 VAC, 50/60 Hz	400 VAC, 50/60 Hz	
	System wei	ight	3420 kg	4200 kg	

(*) One substrate less when optical monitoring is used

HELIOS 800. High-precision, high-yield coaters for mass production.



HELIOS 800 with autoloader – well established in semiconductor industry

The highly precise coating capabilities paired with the automatic loading system makes the HELIOS 800 machine an ideal choice for coating 8" wafers from glass or silicon material. Due to the availability of three loading locks, the machine can be prepared for three continuing and unattended production runs, thus perfectly matching the demands for mass production applications. Of course the machine can be delivered

with a SECS/GEM interface for data exchange and remote control via customers host and data analyzing system.

For processes where frequent changes of the monitoring glass are needed, the loading lock can be easily prepared for automated exchange of the glasses without operator intervention. In such the machine can be prepared and started during the first shift and run production during the next both shifts without any support from the outside.

Key benefits:

- Direct on wafer sputtering
- Optical monitoring with automated test slight exchange
- Unattended operation until the process has been finished
- SECS/GEM Interface

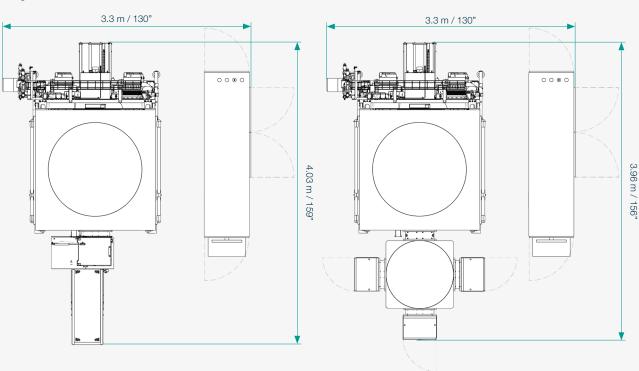
Applications:

- Laser-line filters
- Steep-edge filters
- Single-/multi-notch filters
- Laser mirrors
- Chirped mirrors
- Thin-film polarizers
- Beam splitters
- Bio sensors
- Consumer electronics
- ADAS sensoric

Floor layout: comparison single-load lock and autoloader

Single-load lock

Autoloader



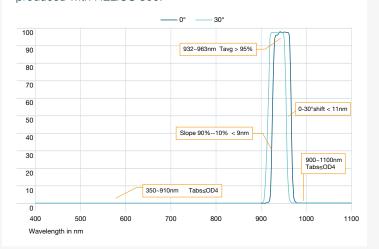
Si:H₂ Process

The optical properties of magnetron sputtered Si-layer can be adjusted by adding hydrogen ($\rm H_2$) to the coating chamber, thus achieving highly transparent layers at 830 nm.

Bandpass filters (Si: ${\rm H_2/SiO_2}$) with low angle shifts were manufactured on HELIOS 800.

Low angle shift filter

Example of how theory and prototype coating of an advanced low angle shift filter perfectly matches when produced with HELIOS 800.



LEYBOLD OPTICS IBS.

Ultra-high precision thin-film coatings.



With LEYBOLD OPTICS IBS 1400 and 1600, Bühler Leybold Optics offers an ion-beam sputtering system for the production of high-precision optical coatings. The technology is well known for extremely low-loss optical coatings and is therefore especially suitable for the production of laser optics.

Key benefits:

- Lowest scatter values and defect densities
- Coating of substrates up to Ø 600 mm
- Highest uniformities of ±0.3 %
- Lowest defect densities due to mask-less deposition
 & operation without shutter
- Coating of curved & large substrates
- Highest flexibility of target material

Options:

- Automatic load lock system
- Additional RF plasma assist source
- Broad Band Monitoring (BBM)

The machine is a batch type system, optional with an automatic load lock system and equipped with an extremely powerful 3-grid RF ion-beam source to be able to produce also large substrates with corresponding quality and speed.

LEYBOLD OPTICS IBS – the ultimate ion-beam sputter coater for your laser, medical, metrology, microscopy and telecom application.

IBS Equipment - a view in the coating chamber



Technical data

Systems		LO IBS 1400	LO IBS 1600		
Coating Technology		Ion beam sputtering with 3-Grid RF source			
Systems High precision (HP)	Laser application	1 x diameter 400 mm substrate	1 x diameter 600 mm substrate		
		Telecom application	1 x diameter 304 mm (12") substrate		
	High throughput (HT)	Medical/Metrology/ Microscopy	4 x diameter 350 mm substrate		
Coating materials			Metallic / dielectric material		
Target configuration			3 – Target assembly		
Sources		Sputter source	3 Grid RF 220 mm		
			LION 100 RF (Single Grid)		
Layer monitoring		Time control	Yes		
		Optical monitoring	LEYBOLD OPTICS OMS 5100 Optional: LEYBOLD OPTICS BBM		
Vacuum system		Pre-vacuum pump	Oil-free pump system		
		High-vacuum pump	Cryo-pump system	Turbo molecular pump system	
Floor space		[m]	3.3 x 5.1 x 2.9	3.5 x 5.4 x 2.9	
		[inch]	130 x 200 x 114	134 x 212 x 114	
Site requirements		Electric power	60 kVA	66 kVA	
		Line voltage	400 V AC, 50/60 Hz		
		System weight	6700 kg	7000 kg	

Markets & applications:

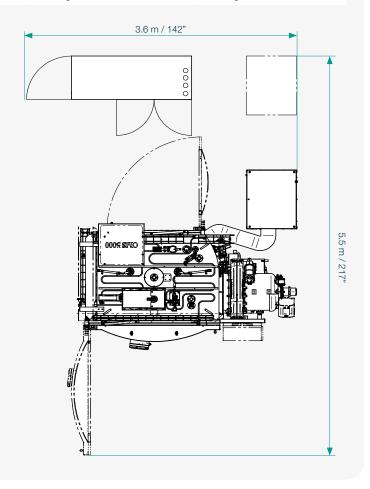
Laser optics

thin-film components:

- AR/HR (antireflex/mirror)
- Gyroscope mirrors
 (Lowest total losses scattering and absorption, Highest reflection)
- Various coatings for laser components
- Medical, Metropoly, Microscopy thin-film components:
 - Bandpass filters
 - Beam splitters(polarizing, non polarizing)
 - Edge filters
 - Dielectric mirrors
 - Metal/Dielectric mirrors
- Telecom

thin-film components:

- LAN-WDM
- CWDM
- DWDM



NESSY series.

The sputter equipment for EUV applications.



- 1 Heated load lock
- 2 Handling for loading/unloading
- Planetary substrate drive with subrotation and speed profiles
- 4 Chamber lid for ease in service
- Magnetron-sputtering cathodes PK 600
- 6 Adjustable sputter distance
- 7 Cryo pump
- 8 Dry pre-vacuum pump set

Key benefits:

- Extremely consistent layer-thickness uniformity
- UHV base pressure: < 9 * 10-9 mbar
- Outstanding, defect-free film quality
- Statistical layer precision in subatomic range (e.g. 7 nm +/- 0.25 %)
- Suited for numerous materials (including Mo and Si for EUV mirrors)

- Advanced layer functions
 (e.g. diffusion barrier and capping layers)
- Adjustable sputter distance
- Substrate height including carrier up to 240 mm
- Substrates sizes up to Ø 660 mm



NESSY series -

sputtered layers with ultimate precision

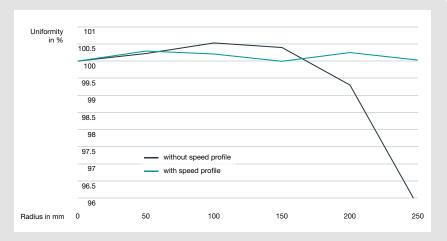
This magnetron-sputtering system used for ultra-high vacuum regimes (UHV) excels with unmatched levels of layer precision through its unique substrate handling with double rotation. Thus it is an ideal tool for the production of mirrors in the x-ray or extreme-ultraviolet (EUV) spectral range. The reflectance values realized on multi-layer stacks come close to the theoretical threshold with economic cost-per-piece ratios in parallel. As such the NESSY platform is equally suited for both series production and for product development at the technological limit.

Application potential

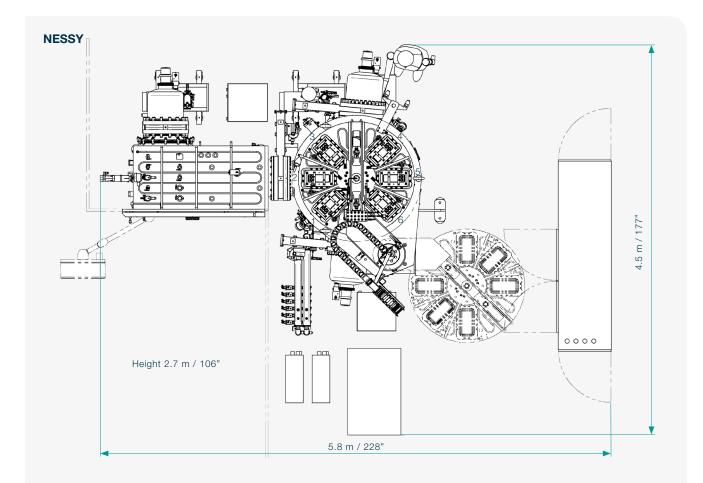
Extreme layer specifications like molybdenum/silicon multi-layer mirrors with maximum reflectance at a wavelength of 13.5 nm, which are of crucial importance as condenser or projector mirrors in lithography equipment, can be realized using the NESSY series. The potential of the NESSY series, however, stretches way beyond this highly specific use. The wide variety of sputtered materials, together with the ability to handle large or complex-shaped substrates, makes the NESSY series ideally suited for the development of novel applications and components. If you have ideas and requirements at the edge of today's technological feasibility, just contact us – we'll accept the challenge!

Unmatched thickness uniformity

Excellent stability of sputter process and extreme levels of layer-thickness precision is a result of careful management of the substrate movement and minimized mechanical tolerances at the substrate holder. With additional double-rotation and varying speed profiles, the NESSY series bridges the gap to the subatomic uniformity values necessary in, for example, EUV optics applications.



Uniformity of molybdenum single layer measured by optical density. The data show \pm 0.15 % over 450 mm diameter in the optimized case.

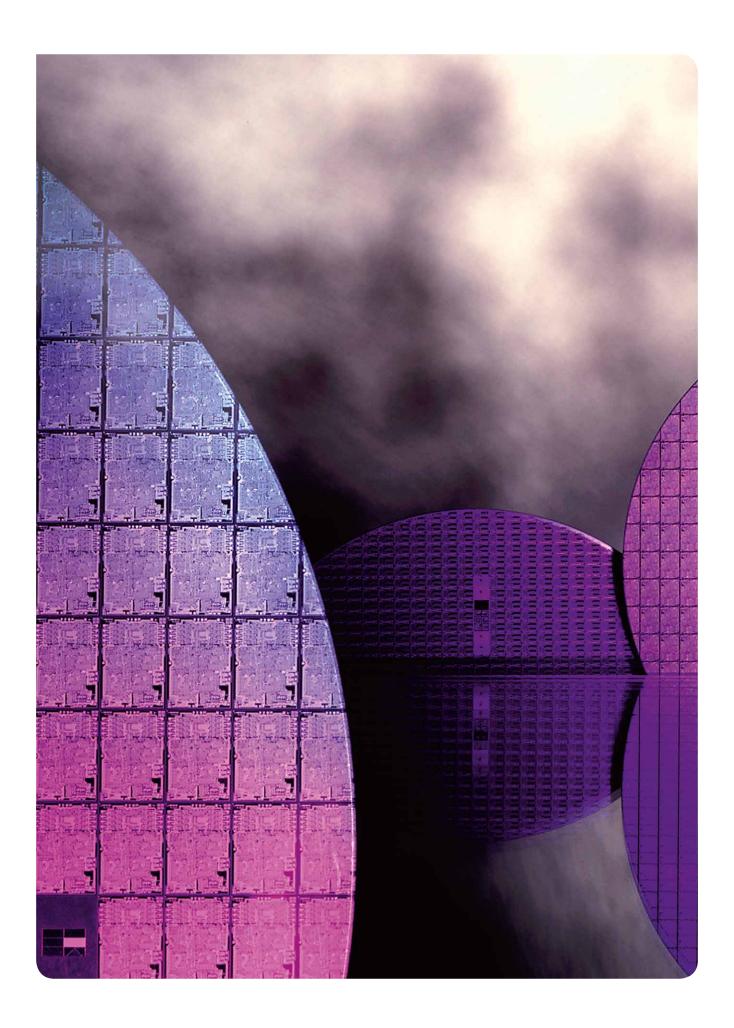


Technical data

Systems		NESSY 1200	NESSY 1900	
Coating technology		DC or DC pulsed sputtering (optional: RF sputtering)		
Coating material		Mo, Si, Cr, Sc and different materials for diffusion-barrier layers and capping layers		
Sputter source		Up to 6 PK	Up to 6 PK	
		250 mm x 100 mm	600 mm x 125 mm	
Base pressure		9 * 10 ⁻⁹ mbar	9 * 10 ⁻⁹ mbar	
Planetary-drive speed		0 – 5 rpm	0 – 5 rpm	
Rotation-table speed*		0 – 500 rpm	0 – 500 rpm	
Loading capacity (standard)		1 x Ø 200 mm / 8"	1 x Ø 300 mm / 12"	
		max. 20 kg (incl. carrier)	max. 30 kg (incl. carrier)	
Loading capacity (optional)		n.a.	1 x ≤ Ø 660 mm / 26"	
			max. 100 kg* (incl. carrier)	
Floor plan layout **	Footprint	5.8 m x 4.5 m / 228" x 177"	7.0 m x 6.5 m / 276" x 256"	
	System height	2.7 m / 106"	2.9 m / 114"	
Site requirements	Electric power	94 kVA	94 kVA	
	Line voltage	400 VAC, 50/60 Hz	400 VAC, 50/60 Hz	
	System weight**	7500 kg	9700 kg	

^(*) For heavy substrates the rotation speed is limited

^(**) System weight and dimensions can change in accordance with customer requirements



DEIMOS 5500.

High-quality coatings for astronomical mirrors.



DEIMOS 5500 – the new sputter coater for substrates up to \emptyset 4.5 m / 15 ft.

The DEIMOS 5500 vacuum coating system is designed for the coating of astronomical mirrors by means of sputter technology. Typically, aluminum (Al) and silver (Ag) targets are used to form protective and enhancing layers in order to achieve the highest reflectance and durability.

Prior to processing, both the substrate and the chamber will be precleaned by either mid-frequency (MF) or direct current (DC) glow discharge.

For easy substrate exchange, the lower chamber-half is mounted on a rail system so that it can be easily moved to a clear space to allow access for the substrate handling crane.

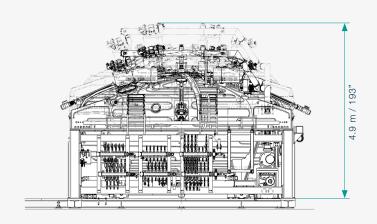
Key benefits:

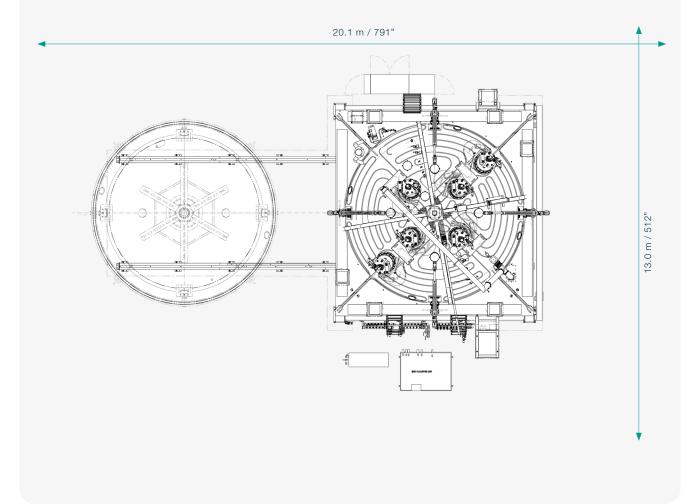
- 4-magnetron assembly
- Highest reflection and coating durability
- Movable cathode inclination for perfect adaptation to substrate curvature and excellent layer uniformity
- Coating of curved substrates up to Ø 4.5 m / 15 ft.
- Protected and enhanced Al or Ag mirrors
- Pre-cleaning of chamber and substrate via MF or DC glow discharge
- Lower chamber-half on rails for easy substrate exchange

Technical data

General design features		Components	
Loading capacity	Up to 8 tons weight	Cathodes (4 pcs.)	LEYBOLD OPTICS
Max. substrate Ø	4.5 m / 15 ft.	Sputter target	Al, Ag, Nb, Si
Rate monitoring	4 x quartz-crystal head	Sputter power supply	DC and DC pulsed
Remote access	LAN/WLAN/air card	Uniformity	< ± 5 %

Deimos 5500





STARpro. Versatile coating system for small-batch optical filter production.



- 1 Separate load-lock
- 2 Adjustable sputter distance
- 3 Ergonomic graphical user-interface (GUI)
- 4 Integrated cooling water system
- 5 Three gas cylinders can be incorporated

Small, fast and precise

Bühler Leybold Optics' STARpro is a reactive single magnetron-sputtering system that covers a wide range of applications through the use of $\mathrm{Si_3N_4}$ and $\mathrm{SiO_2}$ multi-layers. The system is very easy to install and operate. Moreover, the STAR achieves spot-on accuracy and high reproducibility throughout the entire target lifetime via the implementation of the premium optical monitoring system LEYBOLD OPTICS OMS 5100.

Applications:

- Anti-reflection (AR) coatings
- Bandpass filters
- Edge filters
- Dielectric mirrors
- Dichroics

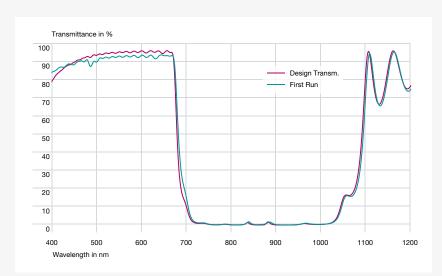
Key benefits:

- Separate load-lock chamber for:
 - higher process stability
 - low particle contamination
- Adjustable sputter distance
- Planetary system for high uniformity
- High deposition rates of up to 2 nm/s
- Plug-and-play:
 - Extremely easy to install and operate
- Very compact footprint (~1 m²/11 sq. ft.)
- All components in one base frame

Technical data

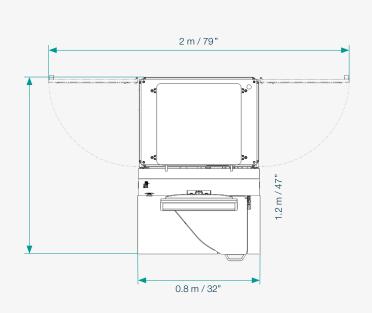
General features		Components	
Loading capacity	4 substrates	Cathode	LEYBOLD OPTICS PK150
Max. substrate Ø	80 mm / 3.51"	Sputter target	Silicon (Si)
Process gas N ₂ . O ₂ . Ar	Incorporated	Sputter power supply	DC pulsed
Optical monitoring	LEYBOLD OPTICS OMS 5100	Sputter rate SiO ₂	1.2 – 2.0 nm/s
Remote access	LAN/WLAN/air card	Sputter rate Si ₃ N ₄	0.7 –1.2 nm/s

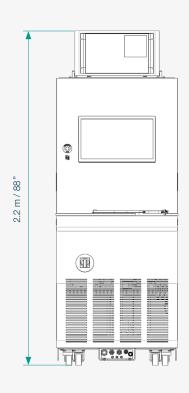
IR-cut filter



Excellent performance with the first run due to LEYBOLD OPTICS OMS 5100 in-situ optical monitoring system.

STARpro





LEYBOLD OPTICS DLC.

The reference high-precision PECVD system.



LEYBOLD OPTICS DLC 600 -

the diamond-like carbon coating system

The LEYBOLD OPTICS DLC 600 coater operates under high-vacuum conditions and uses plasma-enhanced chemical-vapor deposition (PECVD) technology. These machines are

used by industry leaders for precision optics applications to produce mainly optical and thermal imaging systems. The Bühler Leybold Optics R&D and process team is your partner for customized processes.

Key benefits:

- Benchmark uniformity across entire coating area
- Excellent reproducibility via optical monitoring
- Wide variety of substrate sizes
- Suitable for flat and curved substrates
- Highest end-product quality

Applications:

- Diamond-like carbon (DLC) layers
- Anti-reflective coatings
- Substrates: Ge, Si and others
- Optical imaging
- Thermal imaging
- Night-vision equipment
- Distance control

Technical data

Coating technology	PECVD coating system (Plasma-enhanced chemical-vapor deposition)
Coating layer	Diamond-like carbon (DLC)
Capacity	Turntable with Ø 465 mm / 18.3"
Power supply (MF)	13.56 MHz

Standard anti-reflection (AR) processes*

On Ge	Tav @ 8.0 – 11.5 µm
On Ge	Tav @ 3.5 – 5.0 μm
On Si	Tav @ 3.5 – 5.0 μm
Durability performance	Standard environmental tests (MIL)

Layer monitoring

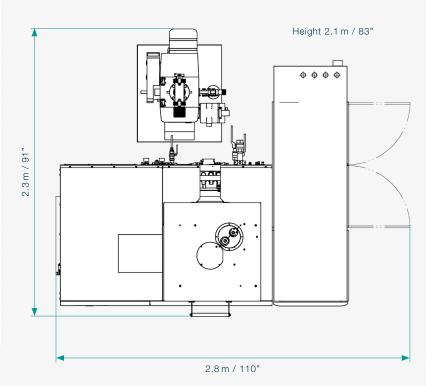
Time control	Yes
Optical monitoring	LEYBOLD OPTICS OMS 5100

Site requirements

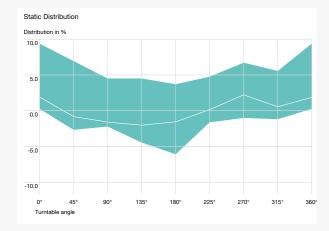
Site requirements			
Footprint	4.4 m x 3.3 m / 173" x 128"		
Electric power	23 kVA		
Line voltage	400 VAC, 3-phase, 50/60 Hz		
System weight	1500 kg		

(*) Other processes on request

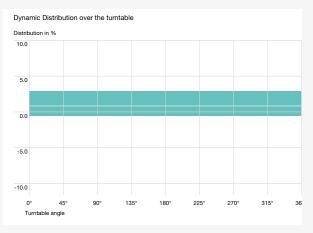
LEYBOLD OPTICS DLC 600



Uniformity characteristics



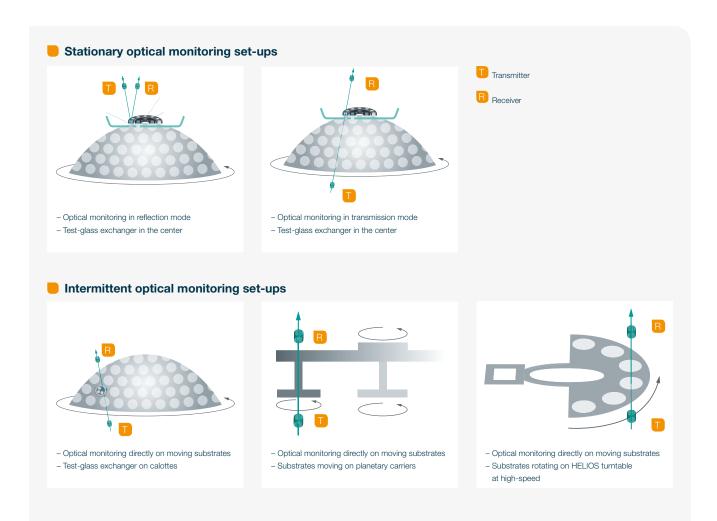
Measured optical properties across different sub-strate positions without rotation.



The operation in dynamic mode with rotating turntable shows perfect uniformity.

Leybold Optics - precision monitoring.

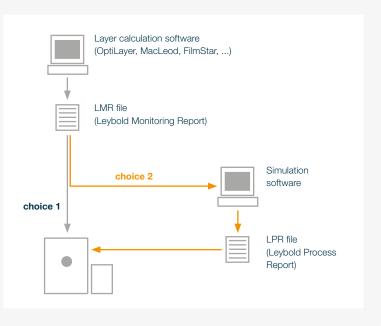
Total process control - perfect product quality.



Bühler Leybold Optics has been setting setting benchmarks in optical monitoring for decades. Direct intermittent measurement – the breakthrough in optical monitoring – was introduced first by Leybold Optics and is used in the SYRUSpro and HELIOS series.

Film design and monitor run-sheet data are interfaced with the coating equipment using LMR or LPR files. Both file formats were invented by Leybold Optics, whereas LMR files are usually generated by most commonly used thin-film design software programs available on the market.

The systems are supported by simulation and pre-production analyzing tools, thus virtually eliminating the need for test- or calibration-runs.



Technical data

	LEYBOLD OPTICS OMS 5100	LEYBOLD OPTICS WB-OMS	LEYBOLD OPTICS BBM
Detector type	Single (PMT, Si, InGaAs, PbS)	Diode array 1024 pixel	CCD array 2048 pixel
Dispersive element	Grating monochromator	Polychromator	Polychromator
Dynamic range	26 bit	16 bit	16 bit
Detector noise rms @ 400 nm	0.0025 %	0.03 %	0.4 %
Detector noise rms @ 1000 nm	0.001 %	0.05 %	0.4 %
rms detector noise best case	0.001 %	0.01 %	0.3 %
Continuous measurement for stationary measurement	Optional: light chopper up to 80 Hz		
Intermittent measurement	Triggered by incremental sensor	Triggered by incremental sensor	Triggered by incremental sensor
Min. data aquisition time	0.8 ms	1.1 ms	2 ms
Time jitter for measurement	< 0.05 ms	< 0.1 ms	< 2 ms
Optical resolution (FWHM)	0.5 nm – 8.8 nm controllable	3.5 nm	1 nm Optional: NIR 5 nm
Useful wavelength range with halogen lamp	330 nm – 2500 nm	400 nm – 1000 nm	380 nm - 1050 nm Optional: NIR 380 nm – 1700 nm
Useful wavelength range with deuterium lamp	200 nm – 360 nm		250 nm - 380 nm

Data evaluation and software features

	LEYBOLD OPTICS OMS 5100	LEYBOLD OPTICS WB-OMS	LEYBOLD OPTICS BBM
In-situ monitor	Intensity vs. time @ single wavelength	Intensity vs. time @ single wavelength plus Transmittance vs. wavelength	Transmittance vs. wavelength
Thickness control	End-point control by monochro- matic strategies (Turning-point, online corrected trigger-point)	End-point control by monochromatic strategies (Turning-point, online corrected trigger-point).	End-point control by calculated thickness
Re-engineering of thickness errors	Offline based on slow spectral scan between the layers	Offline	Online
Re-optimization of remaining layers	Offline based on slow spectral scan between the layers	Offline based on saved spectra	Offline based on saved spectra Optional: online available

Key benefits of the systems

LEYBOLD OPTICS OMS 5100	LEYBOLD OPTICS WB-OMS	LEYBOLD OPTICS BBM
Highest stability and accuracy	Monochromatic and broadband monitor in one system	Easy-to-use. No monitor run sheet required
Premum product with unique reproducibility	High flexibility of end-point control	High light-sensitivity
High degree of error compensa- tion for many layer systems	Re-engineering capability	Re-engineering capability
High tolerance to systematic errors (Calibration, dispersion n,k)	Powerful and easy-to-use graphical user-interface (GUI)	Re-optimization capability

Leybold Optics APSpro - plasma sources.

Most powerful device in the market.



LEYBOLD OPTICS APSpro

Bühler Leybold Optics' proprietary technology APS (Advanced Plasma Source) was introduced in 1992 and delivers maximum performance and productivity paired with its unique ability to produce shift-free optical coatings. In contrast to other sources in the market, low- and high-index materials can be applied with sufficient densification but without additional heating – even for SiO₂. While the main applications of the plasma-ion-assisted deposition (PIAD) process lie in coating materials such as metal oxides and nitrides, it can, however, also be used in coating pure metals and non-metal oxides.

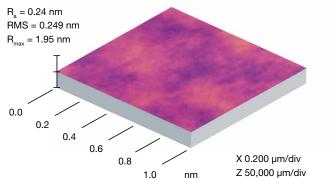
Key benefits:

- Perfect, shift-free spectral performance
- Dense and extremely smooth films
- High deposition rates
- High refractive-index layers
- Wide-angle characteristics
- Enormous library of established processes

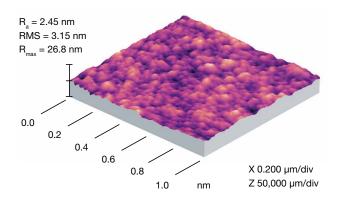
Technical data APSpro

Discharge current	Typical 65 A (max. 100 A)
Discharge voltage	≤ 200 V
Discharge power	≤ 15 kW
Bias voltage	55 - 200 V
Heater power	1.8 kW
Process gas	O ₂ /Ar flow controller
Ion current density	1300 μA/cm² @ 450 mm
Ion energy	20 - 250 eV

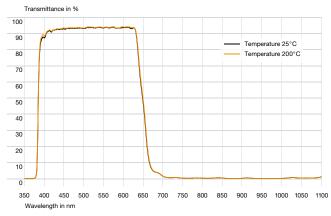
Strikingly better layer smoothness with LEYBOLD OPTICS APSpro



Standard surface roughness with conventional coating



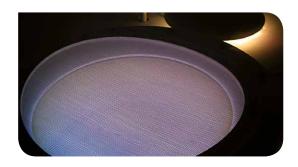
Perfect shift-free characteristics



Optical filter created with APSpro at different temperatures.

Leybold Optics Lion – RF plasma sources.

Ideal for high-performance coatings.



LEYBOLD OPTICS LION

The LEYBOLD OPTICS LION RF source is based on the electron cyclotron wave resonance principle (ECWR). It is completely integrated in our control systems and dedicated for use in large coating systems like the SYRUSpro 1350 and SYRUSpro 1500. These ion sources combine optimum process operation with ease-of-use and low production cost. Moreover, a single grid (mesh) allows for easy and quick maintenance.

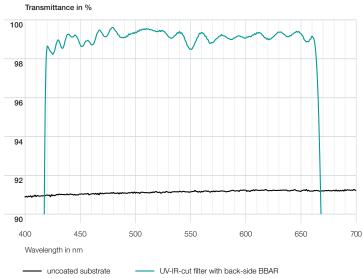
Key benefits:

- Ideal for large chambers
- High power to cover large areas
- High deposition rates
- Layers with very low losses
- Low absorption and scattering
- Easy maintenance
- Low running cost

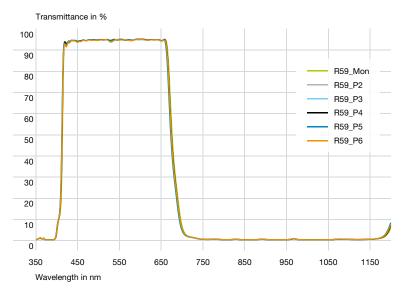
Technical data LION

Free grid-diameter (aperture)	300 mm
RF power	≤ 6.5 kW
Total ion current	≤ 3A
Ion energy	90 – 900 eV
Typical gasses	O2/Ar/N ₂
Matching network	Computerized auto-matching
Ion extraction	Single grid (mesh)

IR-cut-filter



Uniformity



Excellent uniformity over Ø 1400 mm dome ($< \pm 0.5 \%$)

Leybold Optics - evaporator units.

High-performance components.

Thermal-resistance evaporators

Bühler Leybold Optics offers a wide variety of models featuring different numbers as well as volumes of boats. As a result, maximum flexibility combined with optimum equipment configuration can be realized for every application in machines of the SYRUSpro and ARES series.



Low-power thermal-resistance source, (e.g. for hydrophobic top layers)



High-power, highlyflexible single-boat thermal evaporator



High-volume triple-boat evaporator (optional: twin-boat model)

Low-volume electronbeam gun, featuring a precisely controlled energy source.



High-power LEYBOLD OPTICS HPE 12/10 with a variety of porringer sizes and forms.



High-volume LEYBOLD OPTICS HPE 12 with up to 20 pockets and a large ring groove.

Electron-beam guns - LEYBOLD OPTICS HPE series

Based on decades of experience in thin-film technology the LEYBOLD OPTICS HPE series is well known for the reliable evaporation of a large range of coating materials such as oxides, fluorides, metals and sulfides. As such, it is the ideal choice for ophthalmic and precision optics, electronics and optoelectronics applications.

Overview LEYBOLD OPTICS thermal evaporators

System	Operation power	Evaporator boats		
Lower-power thermal-resistance source				
Single-source	7 V / 600 A	1		
High-power thermal-resistance source				
Single-source	3.5 V / 1200 A	1		
Twin-source	3.5 V / 1200 A	2		
Triple-source	3.5 V / 1200 A	3		
High-volume thermal-resistance source				
Hexagon source	3.5 V / 1200 A	6		



High-volume system

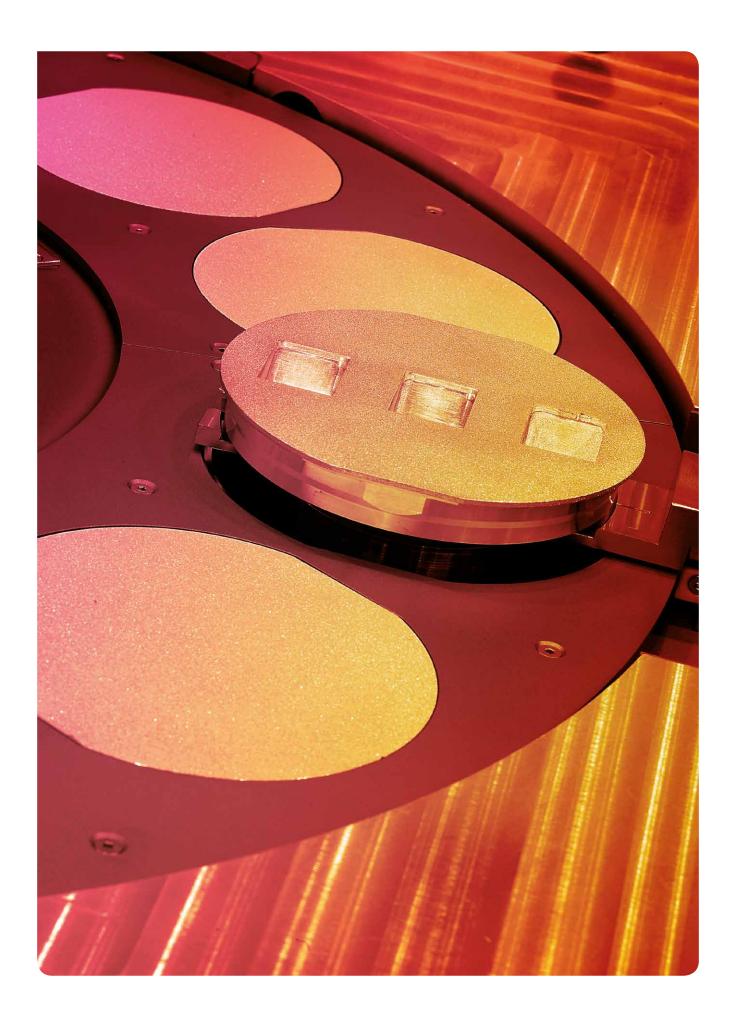
Hexagon source with six large-volume boats. A revolver mechanism places the active source always in the same position – thus ensuring optimum uniformity. The very large volume makes the hexagon source especially well-suited for infrared applications.

Technical data LEYBOLD OPTICS HPE series

System	HPE 6	HPE 12/10	HPE 12		
Beam power (max. output)	10 kW	10 kW	10 kW		
Acceleration voltage (typical)	8 kV	8 kV	8 kV		
Main deflection angle	270°	270°	270°		
Operating vacuum (typical)	< 5 x 10 ⁻⁴	< 5 x 10 ⁻⁴	< 5 x 10 ⁻⁴		
Filament voltage/current	10 V / 32 A	10 V / 32 A	10 V / 32 A		
Cooling water					
Consumption rate	10 l/min	10 l/min	10 l/min		
Inlet temperature (max.)	25 °C	25 °C	25 °C		
Inlet pressure	5 – 6 bar	5 – 6 bar	5 – 6 bar		
Return pressure (max.)	0.5 bar	0.5 bar	0.5 bar		
Dimension (overall)					
Width	126 mm	176 mm	320 mm		
Length	380 mm	394 mm	569 mm		
Height	144 mm	144 mm	144 mm		

Key benefits of LEYBOLD OPTICS evaporator units:

- Large variety of evaporation materials
- Wide deflection angle of 270°
- Programmable range of evaporation patterns
- Crucible types: ring groove, single- or multi-pocket
- Indirect, direct or intensive cooling capabilities
- Quick exchange of cathode and crucible
- Long lifetimes of cathodes and filaments
- Service connections to atmosphere



OPTEG OMF series.

Beyond measurable precision with IBF.



- 1 Fully automated process and control
- 2 6-axis direct drive system
- Grid HF ion beam source
- 4 Aperture changer
- 5 Probe holder according to customer requirements
- 6 Innovative locking system
- Advanced vacuum and cooling system

Ultra-precision as standard

The OPTEG OMF series with ion beam figuring (IBF) technology is the ideal solution for the production of surfaces with an extreme high precision of a few nanometers and a local resolutions in the submillimeter range.

It is a dry error correcting and polishing process under vacuum where accelerated argon atoms ablate nano-scaled particles from the surface of the workpiece.

Nearly all geometries and materials can be processed which makes it perfectly for a broad field of applications – from space, nanotechnology and reflector telescopes to semiconductors, photonics, research industry.

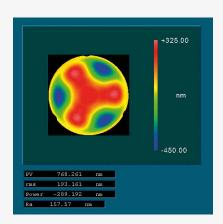
These IBF machines of type OMF are the excellent final processing step, which can be followed by further coating processes with the Bühler Leybold Optics coating machines.

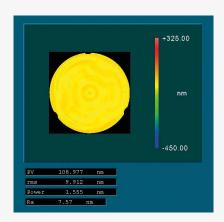
Key benefits:

- Surface qualities of λ/200 and greater
- Processing across the entire substrate surface up to and beyond the edge
- 6-axis direct drive system
- Integrated diaphragm changer
- Integrated load lock for faster workpiece changeover
- High reproducibility

Applications:

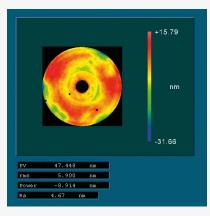
- Lithography optics
- Telescope mirrors
- Deep and extreme UV (DUV/EUV)
- Laser crystals and optics
- Sharp-edged optics
- Precision asphere and freeform manufacturing

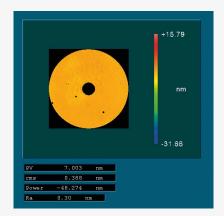




IBF results on various materials

Material BK7: Before IBF (left) and final figure (right). Workpiece properties: flat, Ø 70 mm. 7 x better PV / 19.5 x better rms.





Material SiO₂: Before IBF (left) and final figure (right). Workpiece properties: concave, Ø 200 mm, radius of curvature 339.28 mm. 6.8 x better PV / 15 x better rms.

Further advantages of IBF-technology:

- Easy to use and full deterministic processing
- Processing materials with difficult properties (e.g. extremely soft and porous)
- No force and pressure exerted to the sample (e.g. very thin and sensitive substrates)
- Production of complex optical geometry like aspherical and freeform is almost impossible by manual work
- Up to the edge processing with constant quality (increasing free aperture, ideal for segmented optics)
- Increased throughput / batch processing by full automation
- Predictable processing and lead times
- Treatment of single lens arrays in one batch (e.g. small lenses)
- In-situ etch rate measurement
- No human monitoring required
- Low operating costs and low maintenance requirements

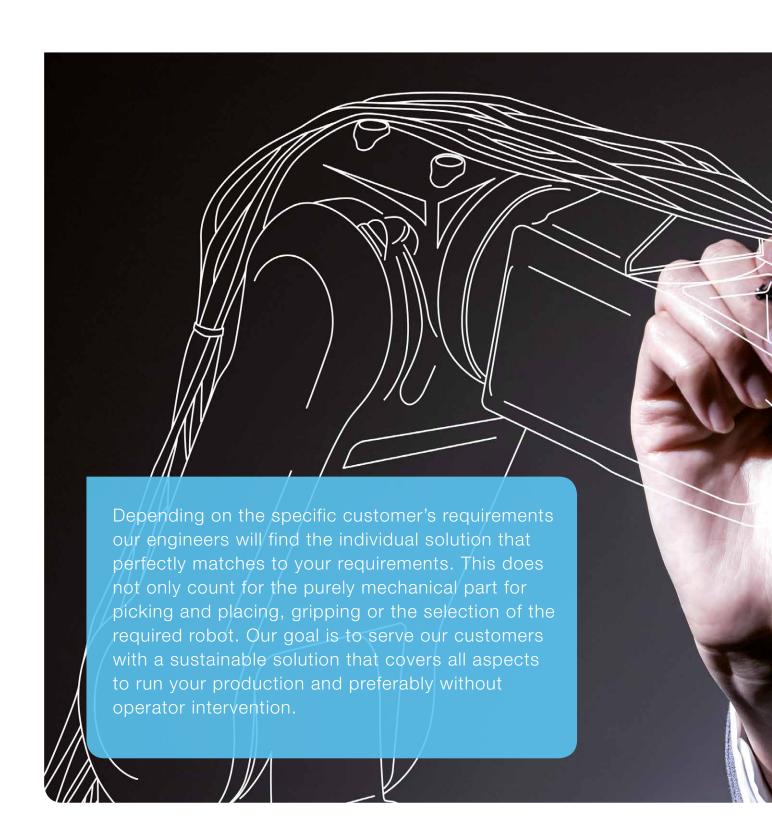
Machine Portfolio

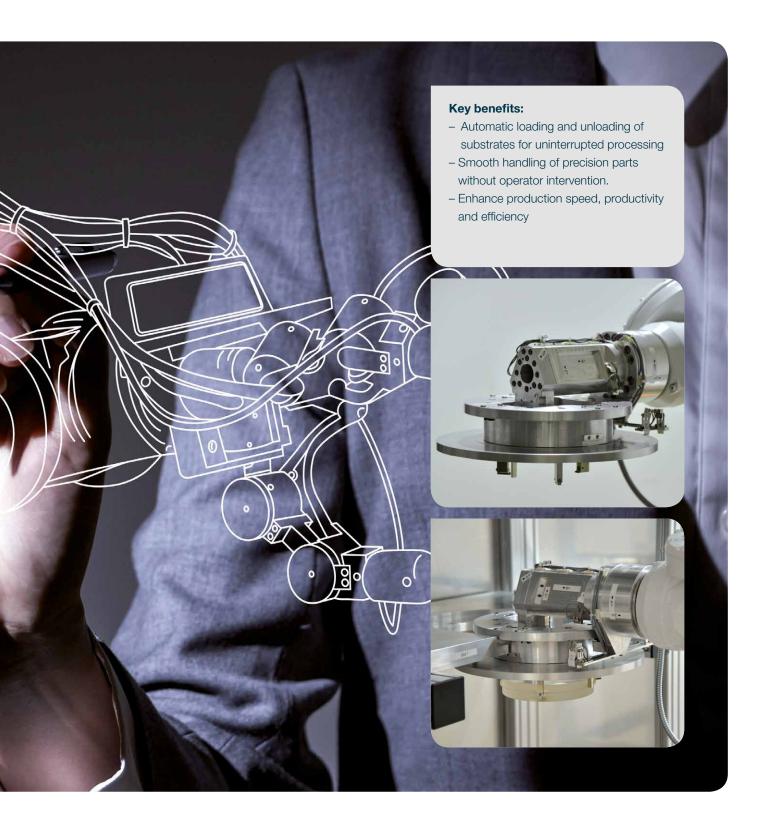
Model	OMF 200	OMF 450	OMF 600	OMF 800	OMF 1200
Max. diameter of flat samples	200 mm	450 mm	600 mm	800 mm	1200 mm
Max. weight of samples	35 kg	35 kg	100 kg	100 kg	200 kg

Options: Fully automated processing via robot handling and workpiece magazines – enables automatic loading and unloading of multiple workpieces for uninterrupted processing.

Bringing your company a step ahead.

Automation solutions made by Bühler.





Customer support and services.

Always on hand to sustain your business.

Global presence of Bühler



Bühler Leybold Optics' relationship with its customers does not end once the machines start production — it is a continuation and an extension of a close partnership. Wherever Bühler Leybold Optics machines are, one of the worldwide centers of competence is close to your site. The company therefore ensures that you receive the right support so that your machines deliver perfect product quality and benefit from high uptime.

Bühler's worldwide customer service as well as the fast delivery of replacement and wear-and-tear parts are just two important aspects of customer support. Preventive maintenance and inspection together with machine reconditioning and upgrading round off the after-sales services. Contact information for Bühler's worldwide services can be found on the company's homepage: www.buhlergroup.com.

Bühler Leybold Optics' service commitment to customers guarantees fast identification of parts, components or consumables, tracked and logged to ensure readiness for shipment within one day so that fast delivery to any country in the world is possible.

Bühler is a specialist and technology partner for precision optics coating solutions. With its expertise and over 150 years of experience, Bühler continuously rolls out unique and innovative solutions for its customers, helping them achieve success in the marketplace. The Bühler Group operates in more than 140 countries and has a global payroll of over 10,000.





Helpdesk

 Always available during German, US and Asian business hours: contact the Helpdesk of your local service or at headquarters. The phone numbers are: EUROPE: +49 6023 500 777 (or +41 71 955 1900)

USA: +1 919 657 7100

CHINA: +86 (10) 67803366-537

- Problems are analyzed promptly via remote diagnosis

Fitness check

Preventive maintenance and inspection

- Full check of all machine functions
- Comprehensive, customer-specific maintenance service for continued optimal productivity and cost savings when repairs are needed
- Monitoring of the maintenance cycle allows timely appointment scheduling

Flexcare / totalcare

Customer service and consultation

- Flexible and adapted to your needs, these service contracts consist of an annual contingency allowance of hours, selectable in different packages – BRONZE, SILVER and GOLD
- Qualified service engineers worldwide
- Quick response times through local resources and close cooperation with suppliers

Replacement parts and accessories

- Worldwide replacement-part-management network, shipment of main parts in one day
- Guaranteed original parts for safe production and highest uptime
- Proven quality for accessories for best qualitative products
- The parts are manufactured by Bühler Leybold Optics or by first-class material specialists like UMICORE with highest availability

Renovation of machines and assemblies

- Software optimization
- PLC and HMI exchange
- Full exchange of electric cabinet and PLC and HMI exchange
- Improved cycle times
- For Leybold Optics products and other machines

Overhaul and upgrades

- Upgrade to new components
- Machine extensions
- Improved performance and longer equipment life
- Used machines with "buy back option" for all Leybold
 Optics products and other machines

Relocation of machines

- Relocation of one machine or a full production site to another production location
- From a precision optics coater to a full production lab

Training

Thoroughly trained and motivated personnel will raise the quality standard that you achieve in utilizing Bühler equipment and will ensure your long-term success. Would you like to increase your employees' level of training to the latest standards in maintenance and operations? To achieve this, Bühler offers you various training courses in a specialized Training Center. In a group of five persons and more, training can be tailored to specific requirements.

- Safety and regulations
- Basics of vacuum technology
- Basics of coating tools
- Basic theoretical training in equipment and technology
- Practical training in preventive maintenance
- Practical training in machine operation
- In-depth training on EB-Gun, Ion source, optical or physical measurement units and process analysis, leak detection, etc.

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